

SIEMENS

PATENT

Attorney Docket No. 2003P12715WOUS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

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|-------------|--|---|-------------------|-------------|
| Inventor: | M. Dankert et al. |) | Group Art Unit: | 2855 |
| | |) | | |
| Serial No.: | 10/589,791 |) | Examiner: | O. L. Davis |
| | |) | | |
| Filed: | August 17, 2006 |) | Confirmation No.: | 3862 |
| | |) | | |
| Title | METHOD FOR RECORDING MICROSTRUCTURAL CHANGES IN A COMPONENT | | | |

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Response Under 37 CFR 1.116

In response to the Final Office Action mailed September 11, 2008, Applicants respectfully submit the following amendments and remarks in connection with the above-identified application to place the claims in condition for allowance or to place the claims in better form for appeal.

(please continue to the next page)